

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Daisuke KOMADA, et al.

Serial No.: **10/058,426**

Filed: **January 30, 2002**

For: **METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE HAVING
SILICON CARBIDE FILM**



Group Art Unit: **1756**

Examiner: **BARRECA, Nicole M.**

Confirmation No.: **4298**

Attorney Docket No.: **020060**

Customer Number: **38834**

RESPONSE UNDER 37 C.F.R. § 1.116
- EXPEDITED RESPONSE -

Mailstop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, Virginia 22313-1450

July 20, 2004

Sir:

In response to the Office Action dated April 1, 2004, Applicant amends the claims as follows and submits the following remarks.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 8 of this paper.